



**INFORMATION DISCLOSURE STATEMENT  
BY APPLICANT**

Date: February 10, 2004

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|                                 |         |                      |
|---------------------------------|---------|----------------------|
| Atty.<br>Dkt. No.               | M#      | Client Ref.          |
|                                 | 0305376 | P-0362.010-US        |
| Applicant: VAN BILSEN et al.    |         |                      |
| Appln. No.: 10/665,404          |         |                      |
| Filing Date: September 22, 2003 |         |                      |
| Examiner:                       |         | Group Art Unit: 2881 |

**U.S. PATENT DOCUMENTS**

| Examiner's<br>Initials* |    | Document<br>Number   | Date<br>MM/YYYY | Name<br>(Family Name of First Inventor) | Class | Sub<br>Class | Filing<br>Date<br>(if appropriate) |
|-------------------------|----|----------------------|-----------------|---|-------|--------------|------------------------------------|
| JL                      | AR | 4,037,969            | 07/1977         | FELDMAN et al.                          |       |              |                                    |
|                         | BR | <del>4,236,805</del> | 04/1982         | FELDMAN et al. 4326805                  |       |              |                                    |
|                         | CR | 4,251,160            | 02/1981         | BOUWHUIS et al.                         |       |              |                                    |
|                         | DR | 4,355,892            | 10/1982         | MAYER et al.                            |       |              |                                    |
|                         | ER | 4,398,824            | 08/1983         | FELDMAN et al.                          |       |              |                                    |
|                         | FR | 4,514,858            | 04/1985         | NOVAK                                   |       |              |                                    |
|                         | GR | 4,540,277            | 09/1985         | MAYER et al.                            |       |              |                                    |
|                         | HR | 4,614,432            | 09/1986         | KUNIYOSHI et al.                        |       |              |                                    |
|                         | IR | 4,690,529            | 09/1987         | SUGIYAMA et al.                         |       |              |                                    |
|                         | JR | 4,710,026            | 12/1987         | MAGOME et al.                           |       |              |                                    |
|                         | KR | 4,748,333            | 05/1988         | MIZUTANI et al.                         |       |              |                                    |
|                         | LR | 4,778,275            | 10/1988         | VAN DEN BRINK et al.                    |       |              |                                    |
|                         | MR | 4,814,829            | 03/1989         | KOSUGI et al.                           |       |              |                                    |
|                         | NR | 4,828,392            | 05/1989         | NOMURA et al.                           |       |              |                                    |
|                         | OR | 4,857,744            | 08/1989         | KATAOKA et al.                          |       |              |                                    |
|                         | PR | 4,861,162            | 08/1989         | INA                                     |       |              |                                    |
|                         | QR | 4,870,452            | 09/1989         | TANIMOTO et al.                         |       |              |                                    |
|                         | RR | 4,952,970            | 08/1990         | SUZUKI et al.                           |       |              |                                    |
|                         | SR | 5,100,237            | 03/1992         | WITTEKOEK et al.                        |       |              |                                    |
|                         | TR | 5,114,236            | 05/1992         | MATSUGU et al.                          |       |              |                                    |
|                         | UR | 5,118,953            | 06/1992         | OTA et al.                              |       |              |                                    |

3-27-07

**FOREIGN PATENT DOCUMENTS**

|    |    | Document<br>Number | Date<br>MM/YYYY | Country | Inventor Name | English<br>Abstract |    | Translation<br>Readily<br>Available |    |
|----|----|--------------------|-----------------|---------|---------------|---------------------|----|-------------------------------------|----|
|    |    |                    |                 |         |               | Enclosed            | No | Enclose                             | No |
| JL | VR | 11-329914          | 11/1999         | Japan   | SAKO TAKASHI  | X                   |    |                                     | X  |
|    | WR |                    |                 |         |               |                     |    |                                     |    |
|    | XR |                    |                 |         |               |                     |    |                                     |    |
|    | YR |                    |                 |         |               |                     |    |                                     |    |

**OTHER (Including in this order Author, Title, Periodical Name, Date, Pertinent Pages, etc.)**

|     |  |   |  |  |  |
|-----|--|---|--|--|--|
| ZR  | Markle, D. A., "Submicron 1:1 Optical Lithography", Semi-conductor International, pp. 173-142, May 1986. | X |  |  |  |
| AAR |  |   |  |  |  |
| BBR |  |   |  |  |  |
| CCR |  |   |  |  |  |

Examiner /John Lee/ (02/18/2007) Date Considered:

\*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.